



*LAW*

PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

September 2, 2005

Applicant(s): Yuji AKIMOTO et al

For: METHOD FOR MANUFACTURING HIGHLY-CRYSTALLIZED  
DOUBLE OXIDE POWDER

Serial No.: 10/611 720

Group: 1755

Confirmation No.: 6093

Filed: July 1, 2003

Examiner: Unknown

Atty. Docket No.: Komatsu Case 287

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

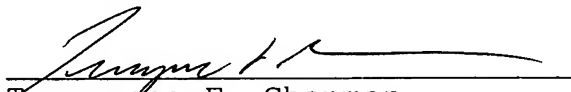
Sir:

In compliance with the provisions of Rules 1.97(e)(1) and 1.98, enclosed herewith is a copy of a Chinese Office Action, Form PTO-1449 and the reference cited thereon.

The undersigned hereby certifies under Rule 1.97(e)(1) that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to filing of this Information Disclosure Statement.

Further consideration is respectfully solicited.

Respectfully submitted,

  
Terryence F. Chapman

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Encl: Copy of Chinese Office Action dated June 10, 2005  
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Applicant(s): Yuji AKIMOTO et al  
Title : METHOD FOR MANUFACTURING HIGHLY-CRYSTALLIZED  
DOUBLE OXIDE POWDER

Serial No. : 10/611 720 Group: 1755  
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Filed : July 1, 2003 Examiner: Unknown  
International Application No.: N/A  
International Filing Date : N/A  
Atty. Docket No.: Komatsu Case 287

Commissioner for Patents  
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Alexandria, VA 22313-1450

**FIRST CLASS MAILING CERTIFICATE**

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 2, 2005.

  
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Sidney B. Williams, Jr.	Reg. No. 24 949

Correspondence: Information Disclosure Statement dated  
September 2, 2005, and all enclosures listed  
thereon

190.05/05

INFORMATION DISCLOSURE CITATION	Applicant: Yuji AKIMOTO et al
	Ser.No.: 10/611 720      Filed: July 1, 2003
	Conf. No.: 6093      Atty. Docket No.: Komatsu Case 287
	Group: 1755

## U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant
	AA			
	AB			
	AC			
	AD			
	AE			
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	AI			
	AJ			
	AK			

## FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Country Code - Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Trans.
	AL				
	AM				
	AN				
	AO				
	AP				

## NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	(Include Author, Title, Date, Pages, Etc.)
	AQ	Shuwang, Y., et al., "Study on Ionic Sieve of Titanium Oxide and Lithium Recovery from Brines", <i>Ion Exchange and Absorption</i> , Vol. 8, No. 3, 1992, pages 222-228
	AR	
EXAMINER SIGNATURE		DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.